



# 21/E  
Amendt E w/RC  
Yokohama  
8/29/03

Docket No.: SON-1690  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Ichiro Fujiwara

Application No.: 09/431,076

Art Unit: 2811

Filed: November 1, 1999

Examiner: H. Vu

For: NONVOLATILE SEMICONDUCTOR  
MEMORY DEVICE AND PROCESS OF  
PRODUCTION AND WRITE METHOD  
THEREOF

**PRELIMINARY AMENDMENT FILED WITH  
REQUEST FOR CONTINUED EXAMINATION**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Preliminary Amendment also serves as a full and timely response to the final Office Action dated March 24, 2003 (Paper No. 15). Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

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